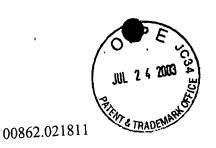
TECHNOLOGY CENTER 2800



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: TADAHIRO OHMI, ET AL.) : :	Examiner: D. Flores Ruiz Group Art Unit: 2828
Application No.: 09/494,945 Filed: February 1, 2000 For: LASER OSCILLATING APPARATU EXPOSURE APPARATUS USING THE SAME, AND DEVICE FABRICATION METHOD	;) : JS,) :)	July 24, 2003
Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450		

PETITION UNDER 37 C.F.R. § 1.136(a)

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated March 24, 2003, for one additional month from June 24, 2003, up to July 24, 2003.

Submitted herewith is a check for \$110.00 to cover the fee for the additional extension under 37 C.F.R. § 1.17. Any deficiency in or overpayment of this fee should be charged or credited to Deposit Account No. 06-1205. A duplicate of this petition is enclosed for that purpose.

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110.00 OP

Applicants' undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Brian L. Klock

Attorney for Applicants Registration No. 36,570

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza New York, New York 10112-3801 Facsimile: (212) 218-2200

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